



Advanced LIGO
**BOSEM Production Status and
EUCLID Development**

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University of Birmingham

LSC-Virgo Meeting

Krakow (Poland)
22nd – 24th September 2010

G1000825-v2

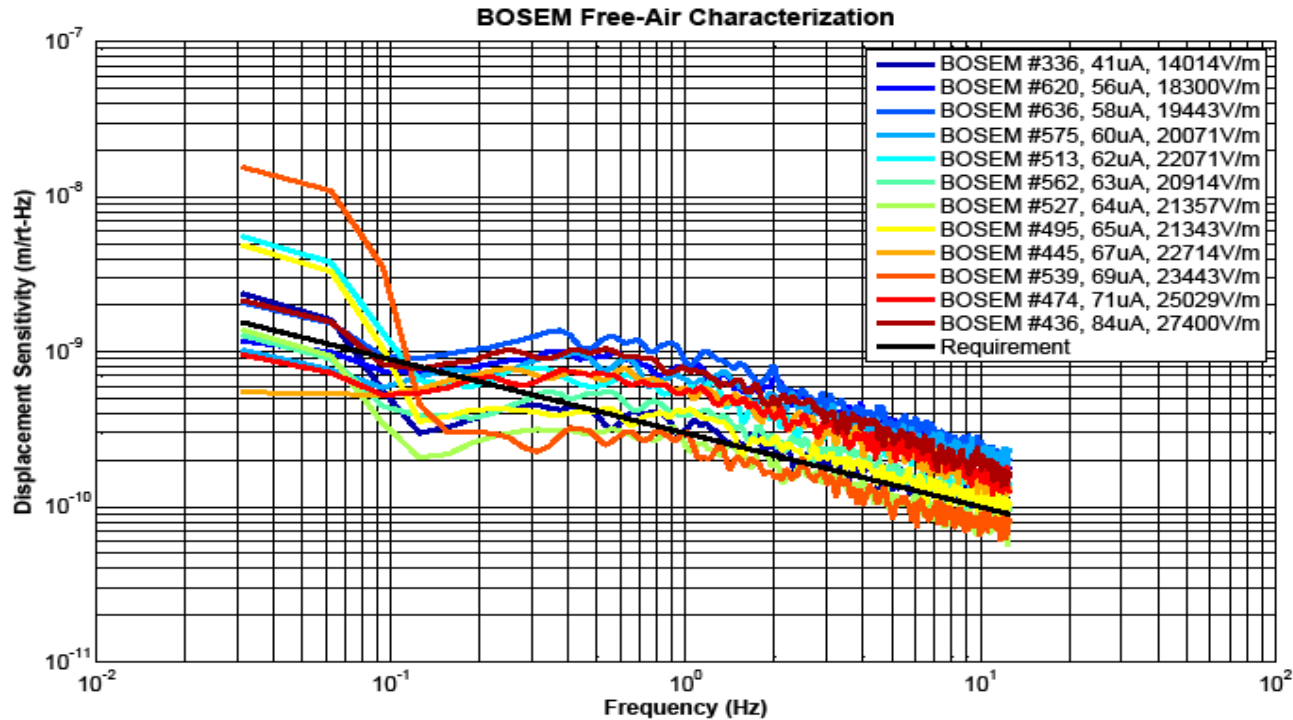


- **BOSEM** *S.Aston, D.Lodhia, N.Lockerbie (University of Strathclyde) and A. Vecchio*
- *Advanced LIGO UK Deliverable*
 - Initial BOSEM Characterisation Results
 - Alternative IRLED Candidate
 - Alternative IRLED Batch-to-Batch Variation
 - IRLED Screening – 1st Batch Results
 - BOSEM Characterisation – 1st Batch Results
 - BOSEM Status & Production Plan
- **Satellite Box & Drive Electronics** *R.Cutler, L.Carbone and A. Vecchio*
- *Advanced LIGO UK Deliverable*
 - Advanced LIGO UK Suspension Electronics (see poster session)
- **EUCLID** *C.Speake, S.Aston, F.Peña Arellano and D. Hoyland*
- *Non Deliverable*
 - Optical Sensor Development
 - Motivation
 - Realisation
 - Fabrication Status
 - Displacement Calibration
 - Tilt Immunity
 - Sensitivity Characterisation





- Requirement [1]:-
 - Sensitivity at 1Hz = $3 \times 10^{-10} \text{m}/\sqrt{\text{Hz}}$ and at 10Hz = $1 \times 10^{-10} \text{m}/\sqrt{\text{Hz}}$
 - Operating Range 0.7mm (peak-peak)



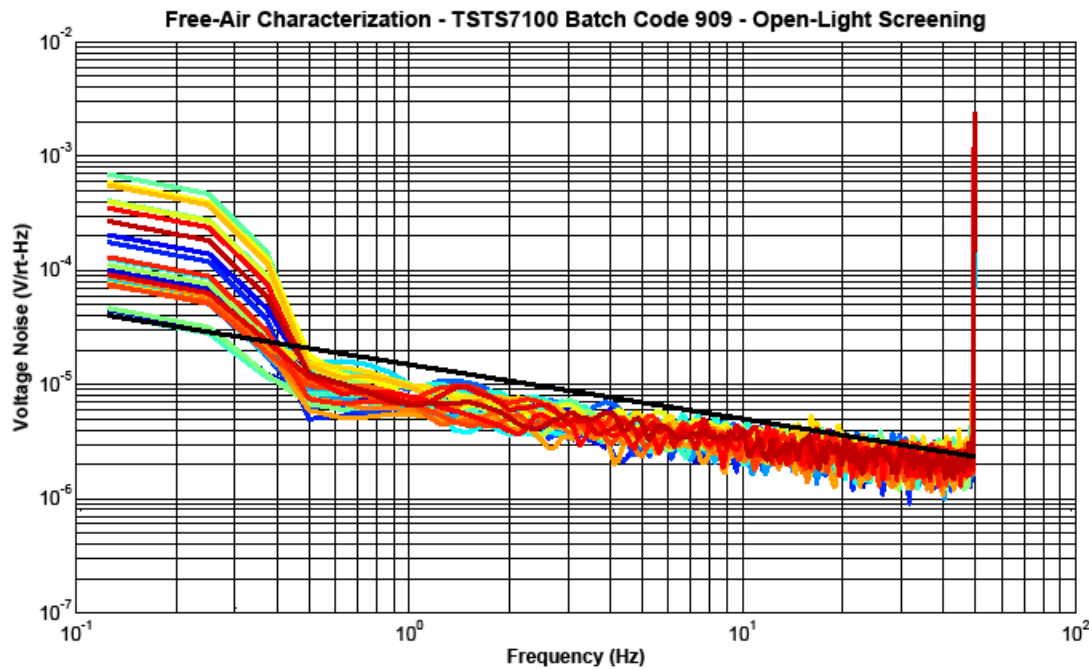
- Results [2] obtained were unexpected & disappointing as only $\approx 10\%$ of units measured met the sensitivity requirement!

[1] T040110-01-K, Ken Strain "Input to the OSEM selection review decision".

[2] T0900496-v2, Stuart Aston "Advanced LIGO BOSEM Noise Measurements".



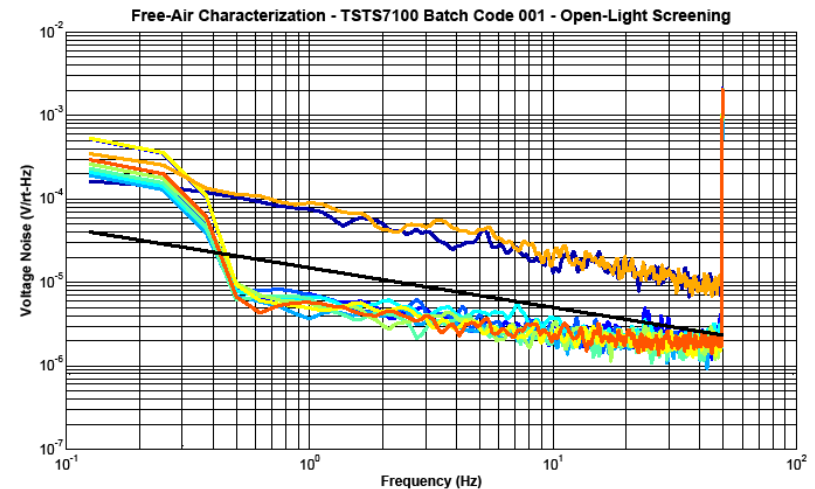
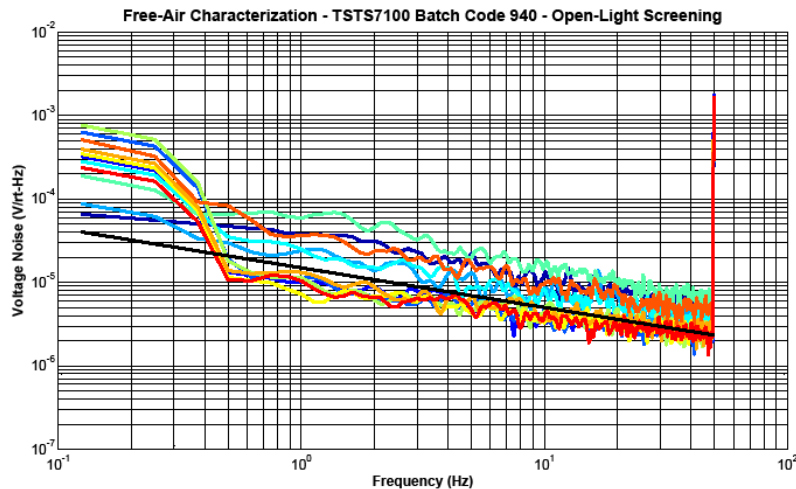
- During testing we identified a promising alternative candidate, Vishay TSTS7100
 - Represents a more recent state-of-the-art device (at similar cost)
 - Opto-mechanical properties of TSTS7100 and OP232 are essentially identical
 - However, pin-outs reversed and TSTS7100 larger forward current capability (250mA)



- 1st batch open-light photo-current noise test results (54 units)
 - Black line illustrates estimated requirement
 - This initial batch demonstrated 100% pass rate (not all traces included in plot)



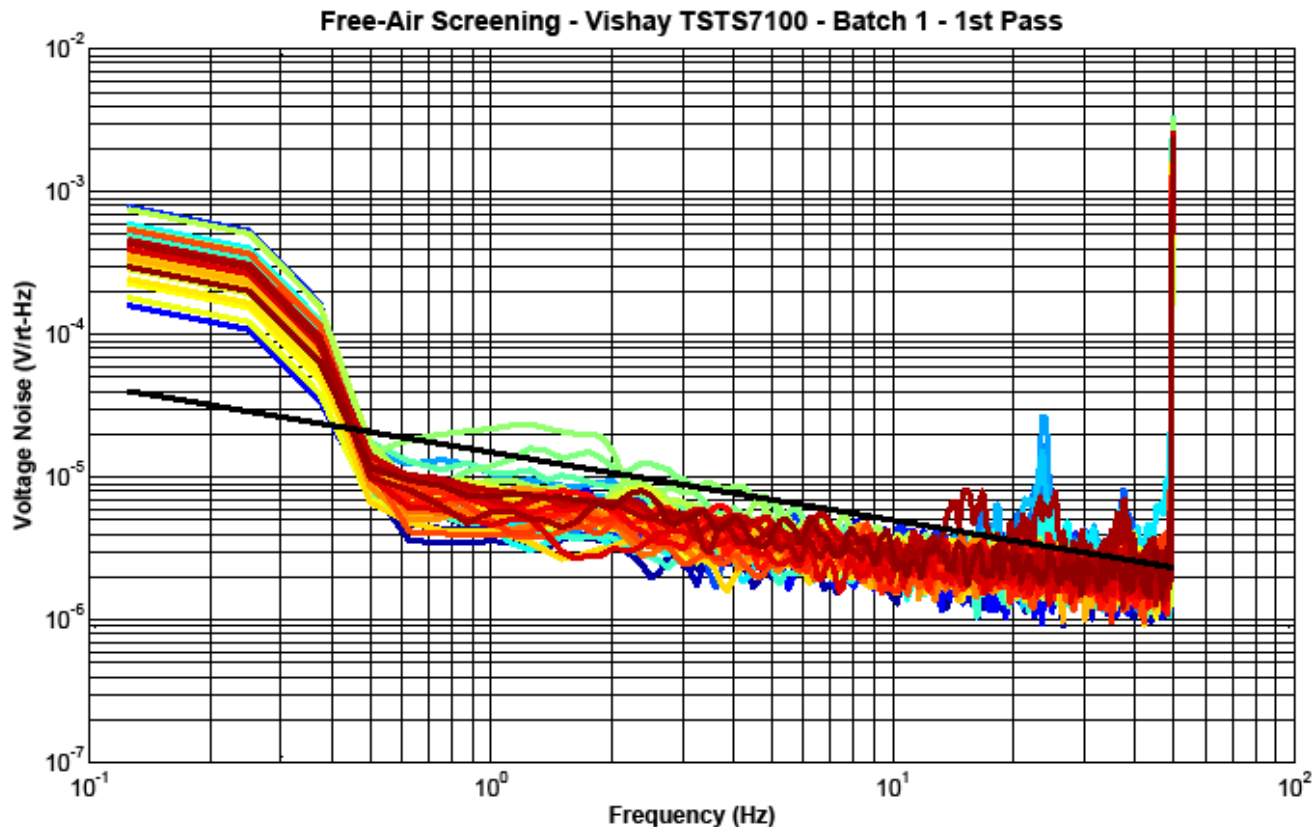
- However, for subsequent batches received the pass rate fell:-
 - 1st batch (909) 100% pass rate (54 tested)
 - 2nd batch (940) ~50% pass rate (11 tested)
 - 3rd batch (001) ~80% pass rate (10 tested)
- ⇒ Indication of significant batch-to-batch variation



- Therefore, screening of photo-current noise offers the only way forward
- Alternative IRLED offers much higher yield than original OP232 device
- We recommended to aLIGO that we should swap devices:-
 - aLIGO UHV qualification was obtained and MTTF data provided by manufacturer



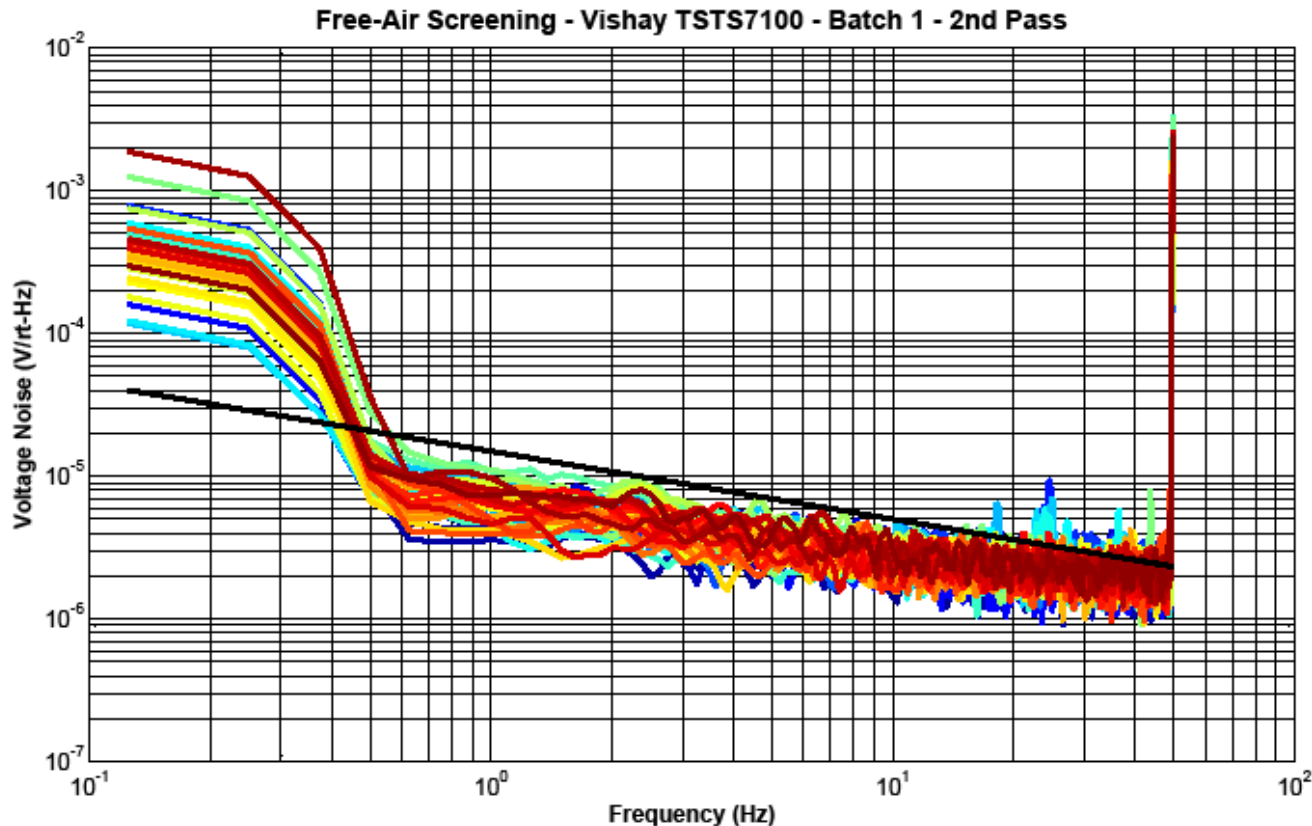
- Vishay IRLED Screening 1st Batch – 1st Pass Results:-



- Screening procedure generated by SMA and undertaken by UoB Technical Staff
- Each batch comprises of 55 units, we are anticipating 60-70% pass rate
- Following on from screening each batch will be burned-in



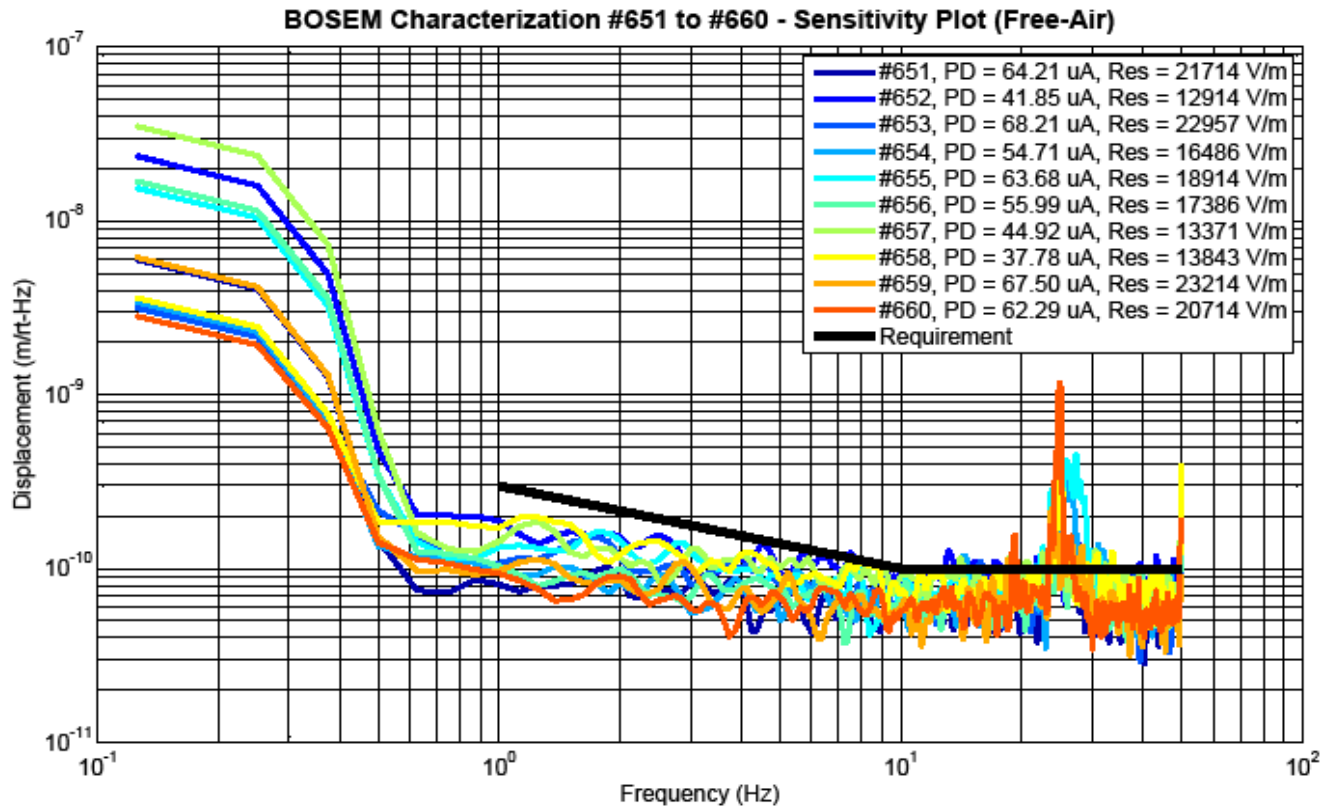
- Vishay IRLED Screening 1st Batch – 2nd Pass Results:-



- SMA analyses traces for each IRLED within batch across requirement band
- Repeat measurements for devices out of specification at other frequencies
- Verification check for repeated, omitted or erroneous measurements



- Assembly of in-process spare BOSEMs (50 units)
 - Incorporating alternative Vishay IRLLED (screened, burned-in, cleaned and baked)



- Complete batch were fully characterised, responsivity and noise measured
- 50 out of 50 BOSEMs meet the sensitivity requirement (black trace)



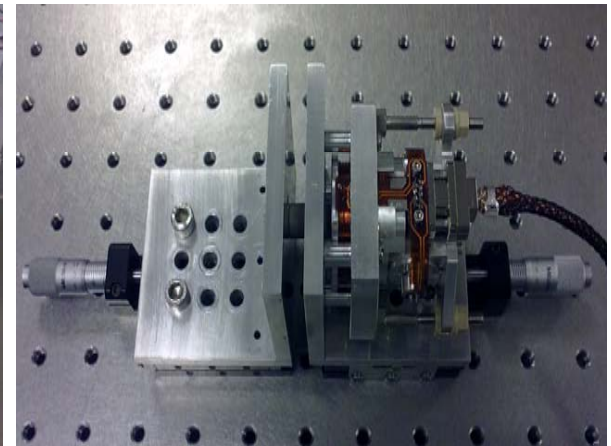
- 103 pre-production units have already been delivered:-
 - NPOSEMs units shipped in December 2007
- 625 production BOSEMs to deliver in total:-
 - 40 shipped for test stands / quad training exercise in April 2010
 - 50 shipped (retro-fitted IRLED and all fully characterised) in August 2010
- 535 remaining to be shipped:-
 - 100% are to be tested during assembly using the Automated Test Equipment
 - 12.5% are to be fully characterised (responsivity and noise measured) s/n #575-#700
- Proposed delivery schedule of shipments of UHV-clean and tested units (with retro-fitted alternative IRLED) to Caltech ≈ 100 per month [3]



Dedicated clean-room assembly facility

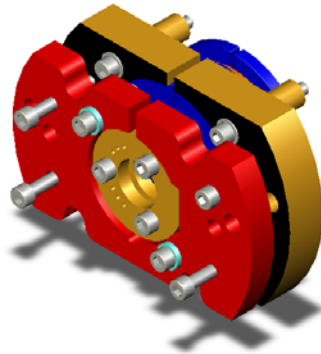


Assembled BOSEMs at ATE station



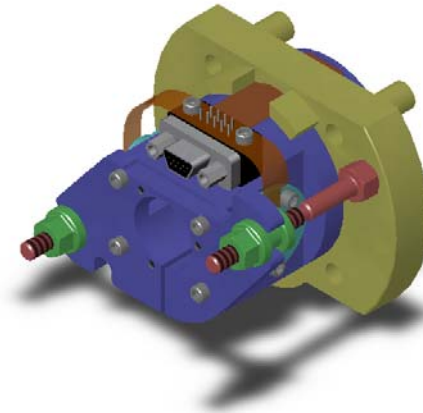
Lab based full characterisation tests

[3] T0900496-v3, Stuart Aston “Advanced LIGO BOSEM Noise Measurements”.



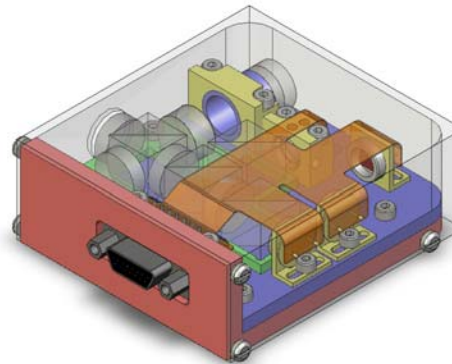
Advanced LIGO

Controls Prototype (Hybrid OSEM)



Advanced LIGO

Noise Prototype &
Production BOSEM

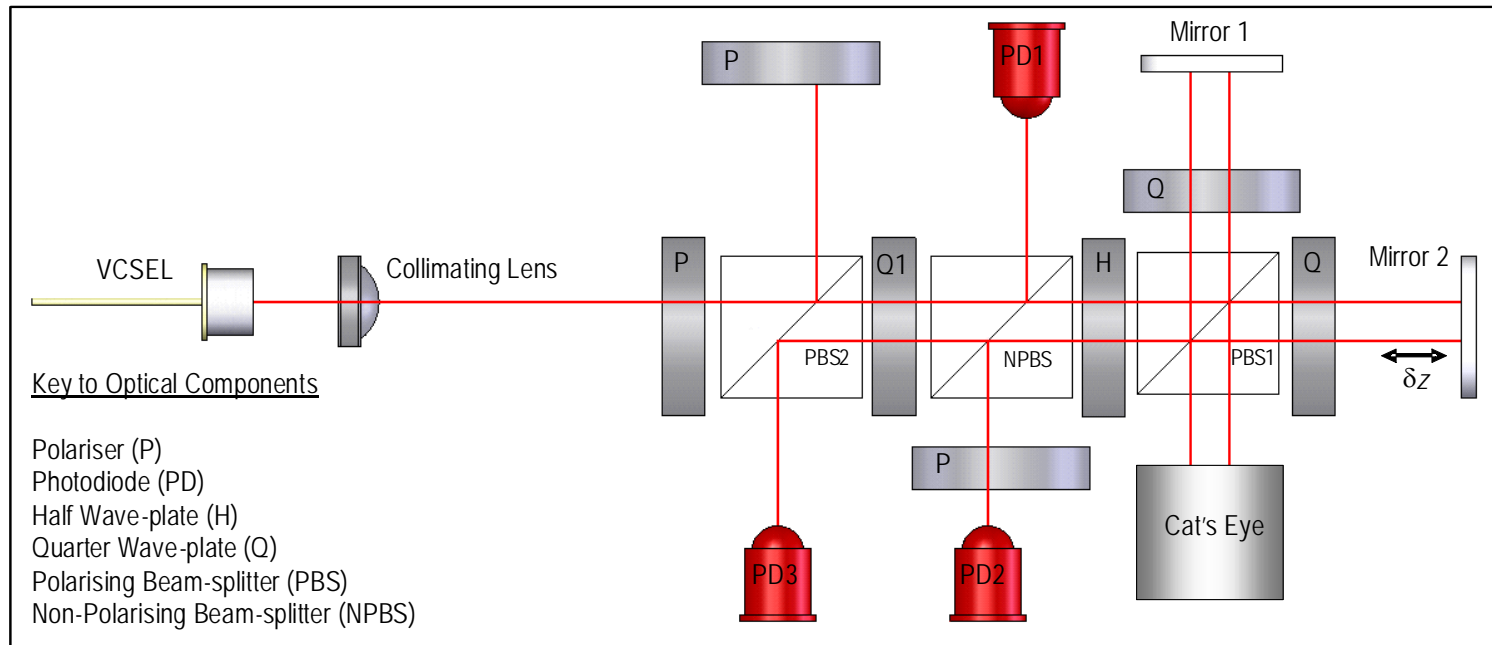


Advanced / Ultra LIGO

Interferometric Sensor (EUCLID)



- We believe BOSEMs offer the best sensitivity you can readily achieve with shadow sensor technology
- To ensure good low frequency stability we needed to avoid active parts that can age, thermally expand, generate heat, exhibit hysteresis, e.g. piezos, AOMs, EOMs etc. This naturally led to a Homodyne Interferometer
- Required to be, compact / portable, and robust against misalignment. This has led us to develop a compact interferometric sensor called EUCLID

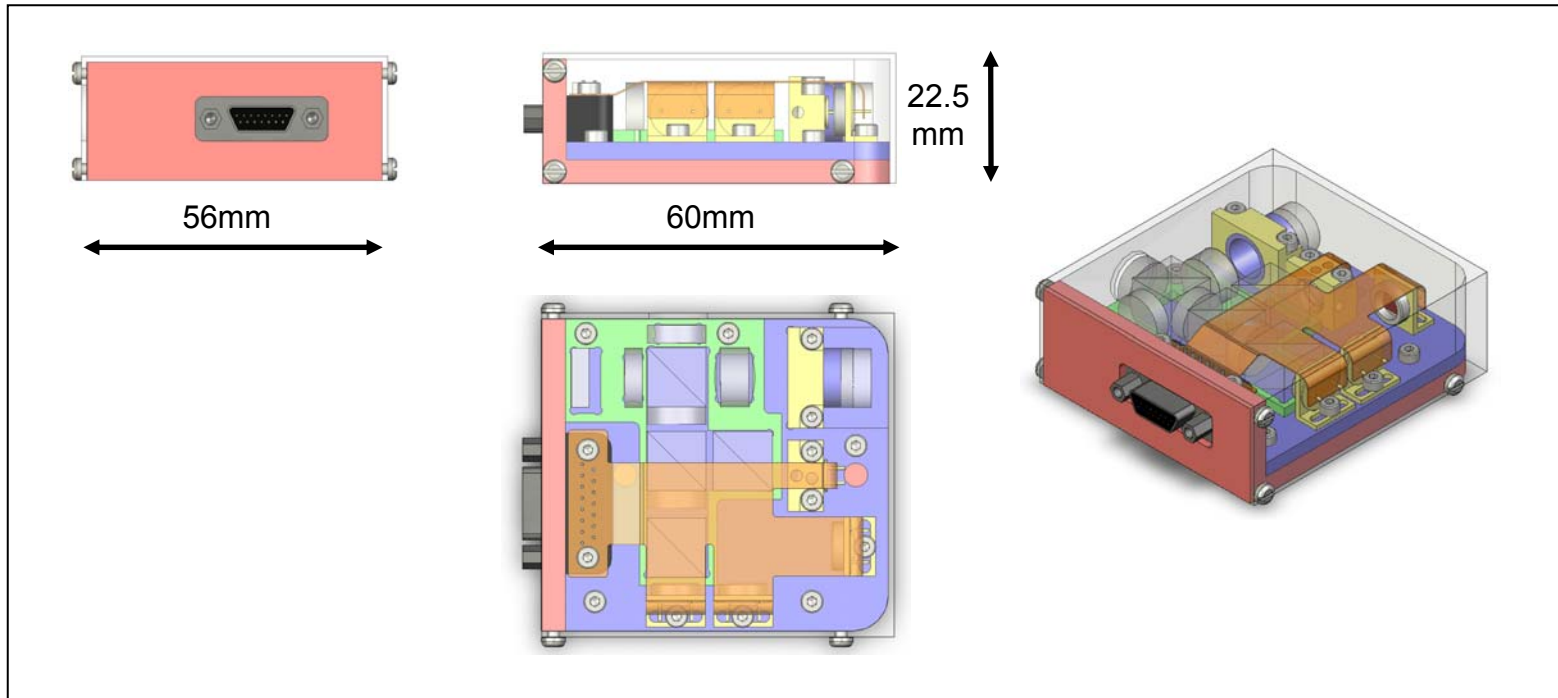


Optical Layout [3]

[3] C. C. Speake and S. M. Aston "An interferometric sensor for satellite drag-free control". IOP, Class. Quantum Grav. 22 (2005)



- Compact dimensions of 60mm x 56mm x 22.5mm
- Robust against misalignment +/- 1°
- Resolution of up to 1 pm/ $\sqrt{\text{Hz}}$ over a large working range > 2mm
- Can be constructed to be LIGO UHV compliant
- Incorporates 667nm VCSEL



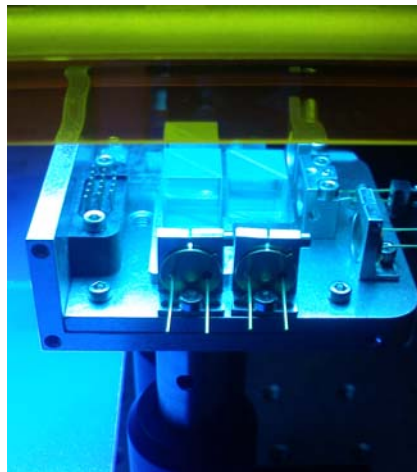
3D CAD Model Engineering Drawing



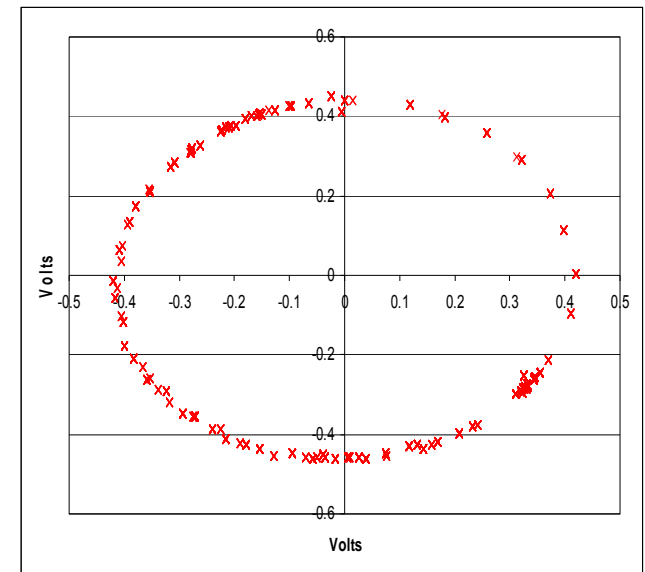
- 4 x EUCLID units have been fabricated so far:-
 - 2 for evaluation at MIT (Rich Mittleman)
 - 1 for evaluation by ONERA
 - Initially 'non' aLIGO UHV compliant versions using Norland NA063 UV adhesive
 - Provided with electronic support equipment (modified satellite box)
 - 3 x output version (+cos, sin, -cos) to remove DC offset from Lissajous pattern
 - Obtained first-light Lissajous figure in March 09



Modified satellite box



UV curing optical adhesive



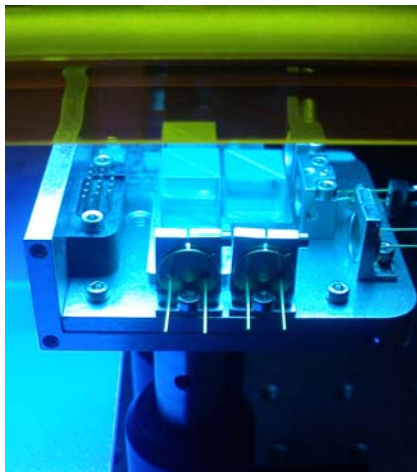
First-light fringe visibility



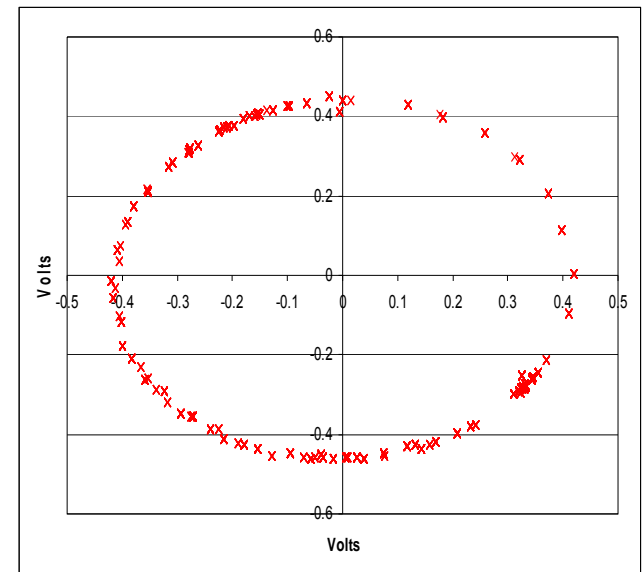
- 4 x EUCLID units have been fabricated so far:-
 - 2 being characterised at MIT (by Rich Mittleman *et al*)
 - 1 being characterised at ONERA
 - Initially 'non' aLIGO UHV compliant versions using Norland NA063 UV adhesive
 - **Now with new electronics support equipment (bespoke onboard FPGA)**
 - 3 x output version (+cos, sin, -cos) to remove DC offset from Lissajous pattern
 - **18-bit ADC's and upto 1MHz sampling**
 - **Operational in August 2010**
 - **Very low-noise front end**



New EUCLID Electronics



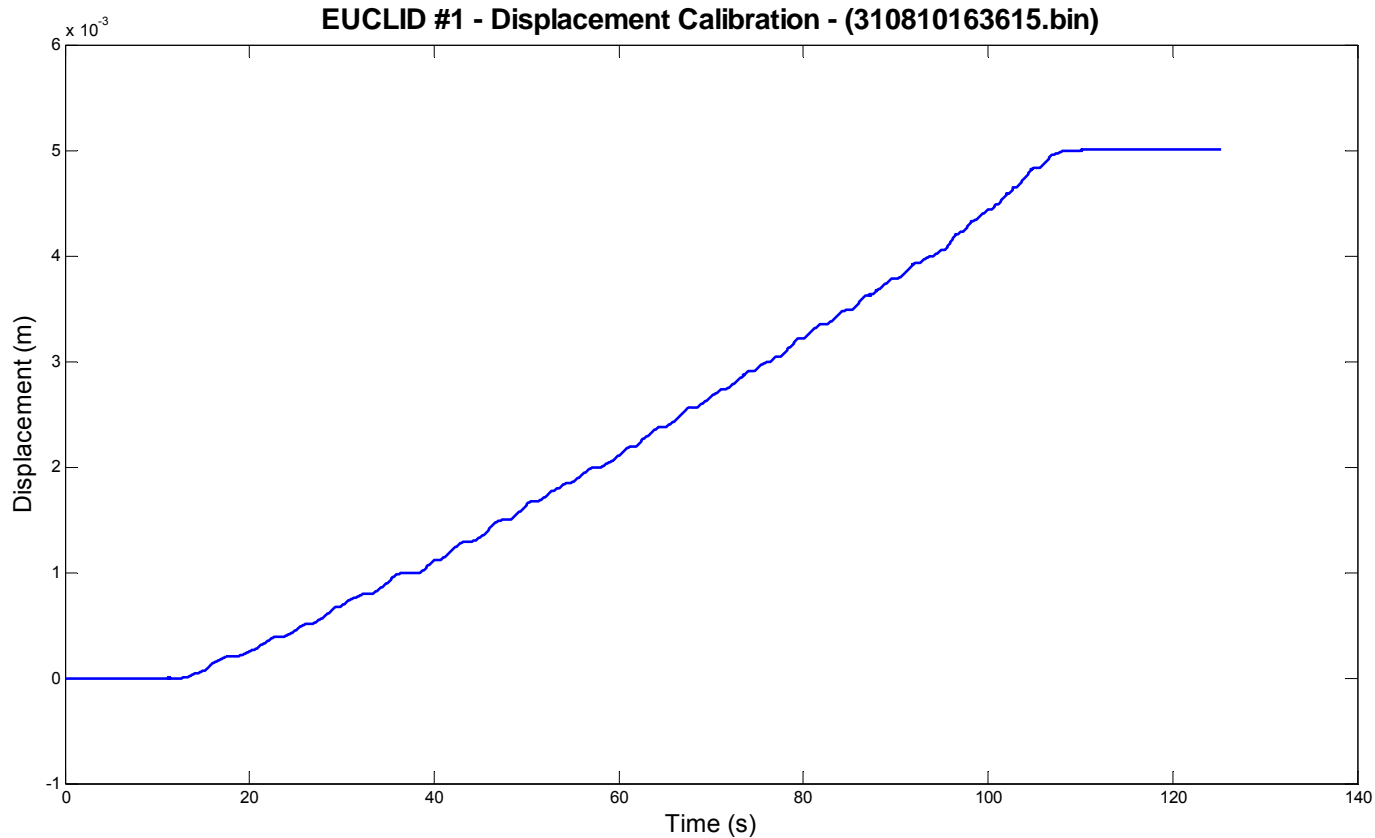
UV curing optical adhesive



Fringe visibility



- High sample rates allows us to track fringes continuously (i.e. not missing any):-
 - Fringes can be tracked over 10mm working range with <1% error

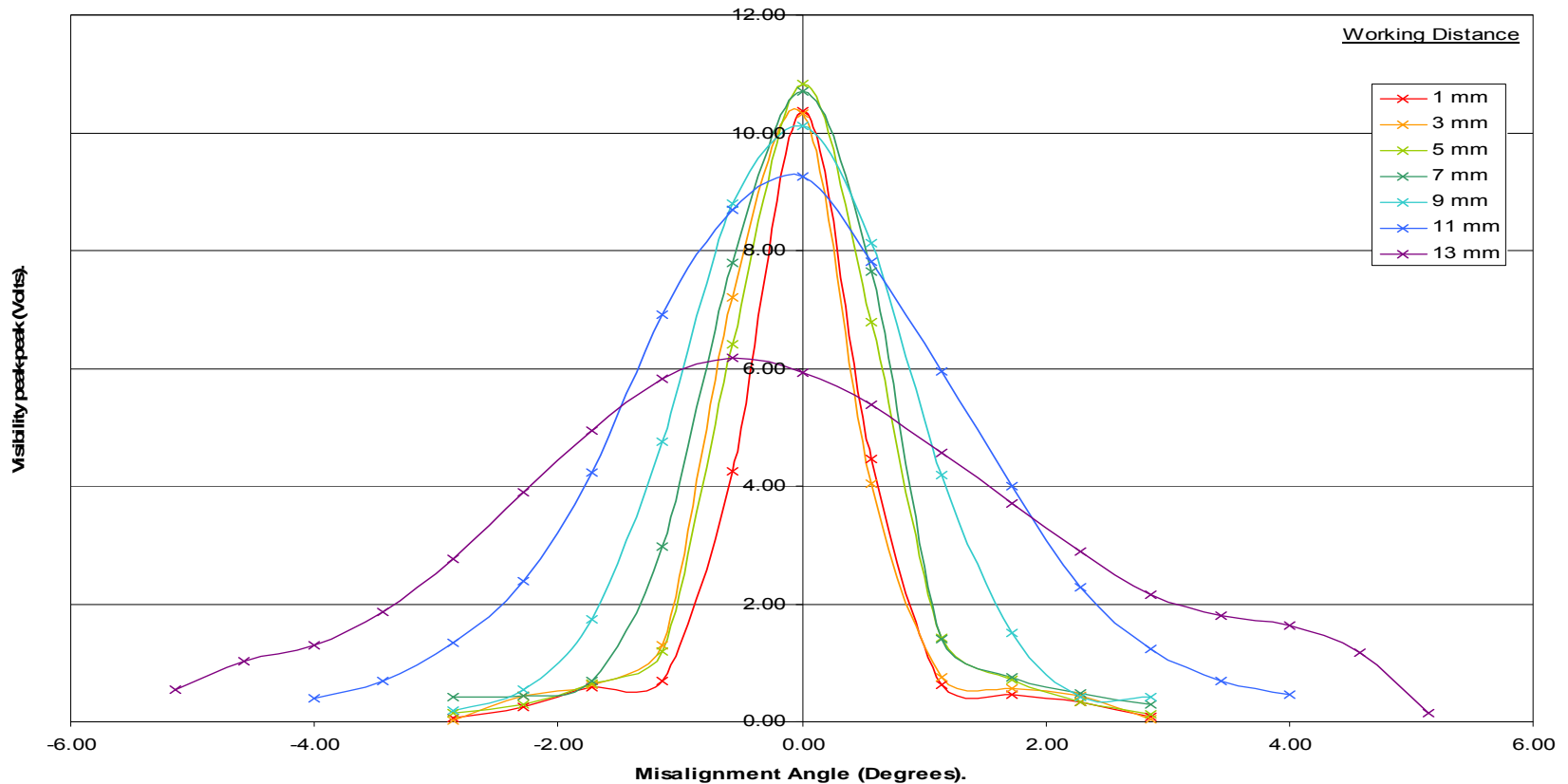


- Plot showing crude calibration measurement over 5mm



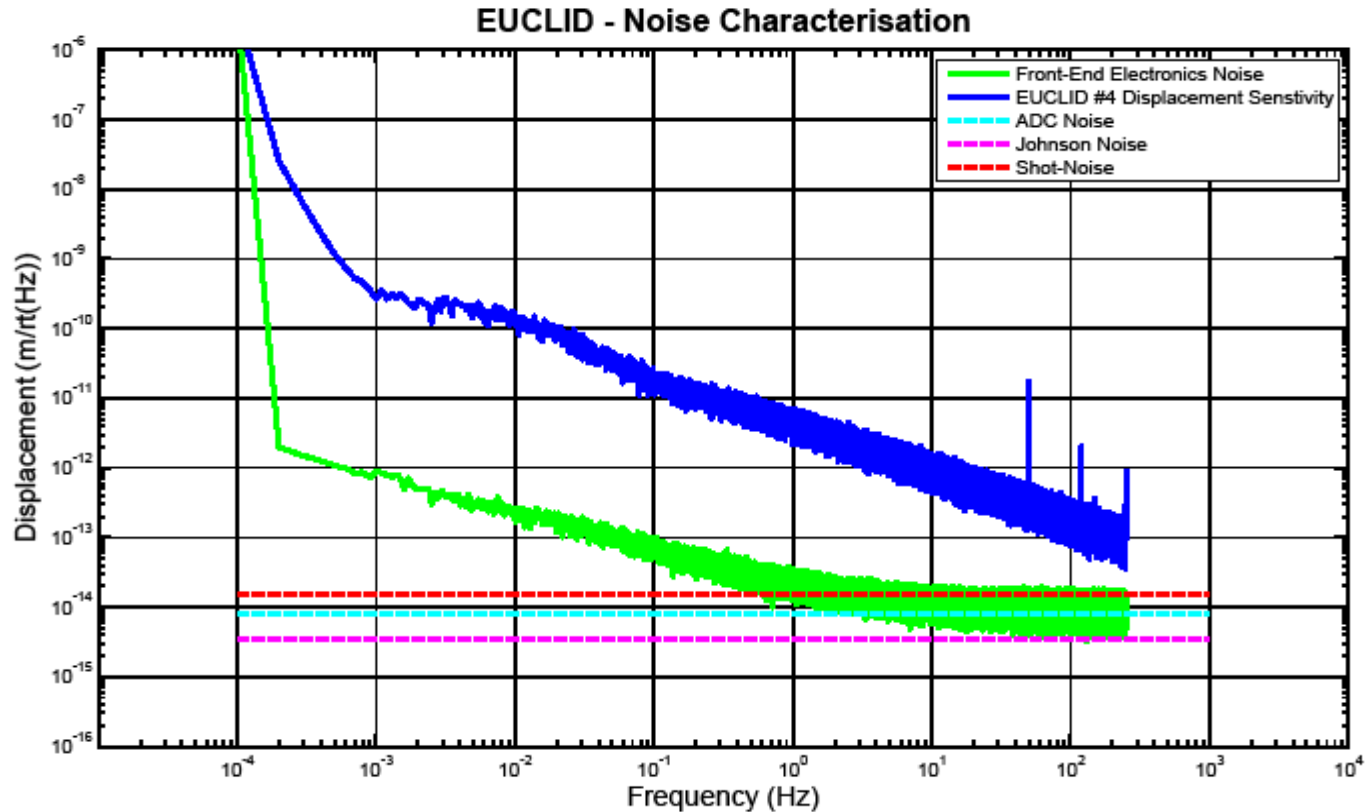
- Misalignment measurements:-
 - Tilt-immunity $\approx \pm 1$ degree
 - Optimal working range ≈ 6 mm

EUCLID 001 - Misalignment Characterisation





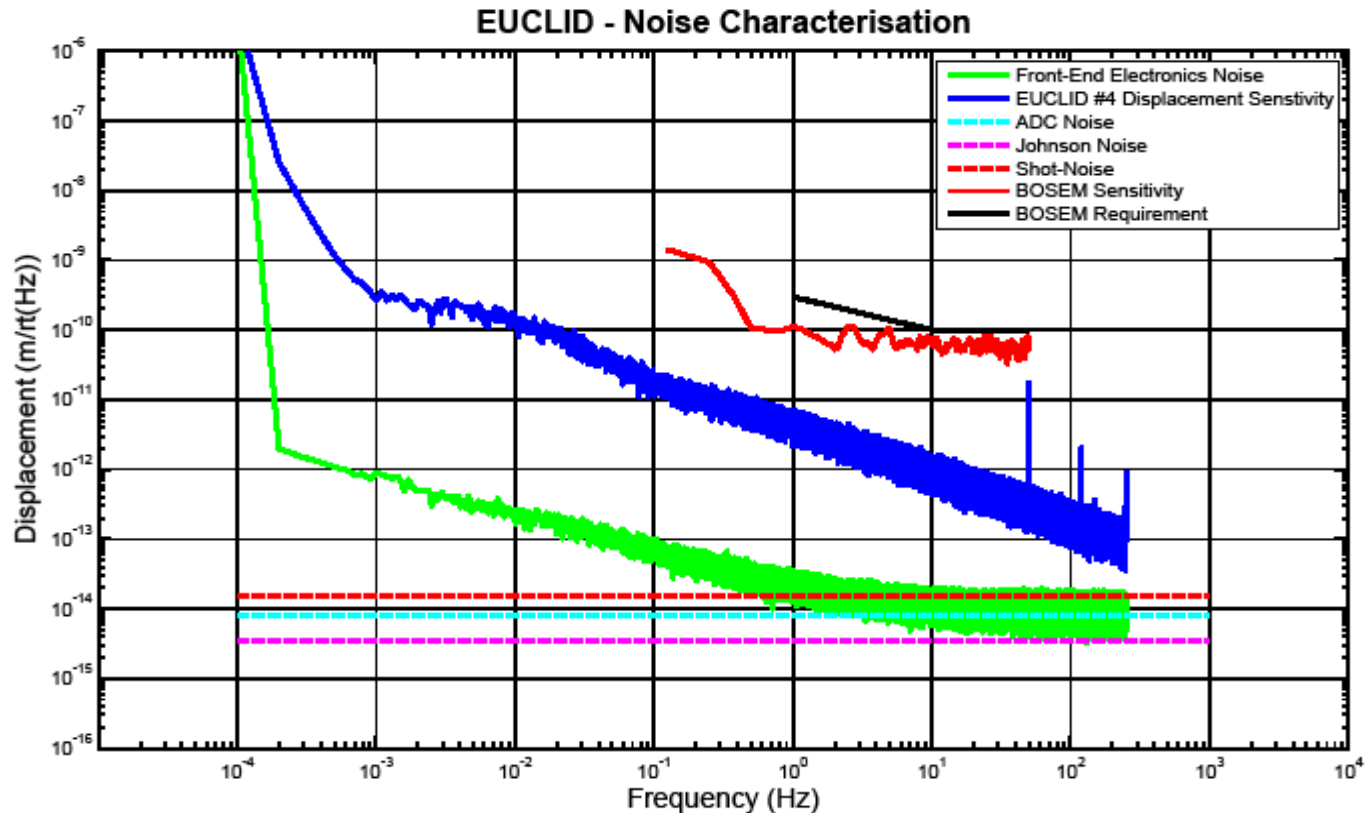
- In Vacuum sensitivity measurements:-



- Achieve a vacuum level of ≈ 10 milliTor (10^{-2} millibar)
- Sensitivity at 1Hz $\approx 5 \times 10^{-12}$ m/ $\sqrt{\text{Hz}}$ and at 10Hz $\approx 1 \times 10^{-12}$ m/ $\sqrt{\text{Hz}}$



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Thank you for your attention